

jc971 U.S. PTO  
09/931324  
08/16/01

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Serial No.: Unknown

Examiner: Unknown

For: Adjustable Dual Frequency  
Voltage Dividing Plasma  
Reactor

CERTIFICATE UNDER 37 CFR 1.10

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on 2-27-2021 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EL849146250US addressed to: Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231.

8-16-21 Date [Signature] Signature

Dear Sir:

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

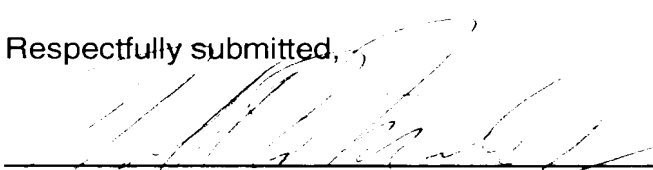
While the information submitted in this Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

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The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/4184/ETCH/CHAMBER/RWM.

Respectfully submitted,



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